



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 11, 2025

IGI Report Number **LG755532462**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **12.49 - 12.57 X 7.37 MM**

GRADING RESULTS

Carat Weight **7.00 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

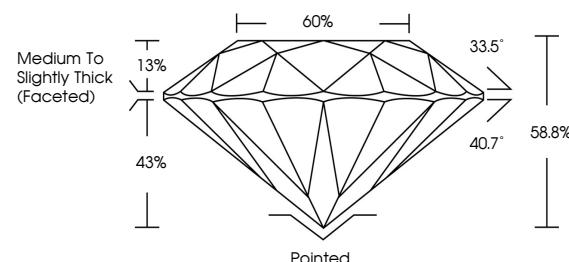
IGI **LG755532462**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

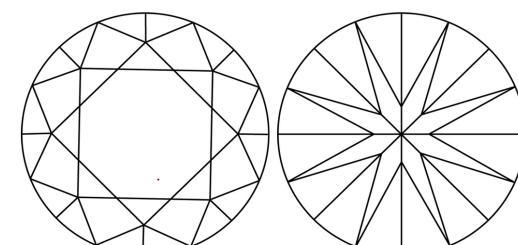
Type Ila

LG755532462
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

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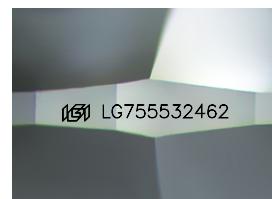
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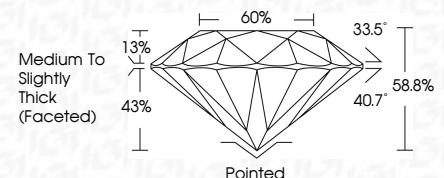
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Sample Image Used



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Inscription(s) **IGI LG755532462**

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12.49 - 12.57 X 7.37 MM	ROUND BRILLIANT
Carat Weight	7.00 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	IDEAL
Depth	58.8%
Table	43%
Girdle	13%
Medium To Slightly Thick (Faceted)	60%
Pointed	33.5°
Flawless	Flawless
Internally Flawless	Internally Flawless
Very Very Slightly Included	Very Slightly Included
Very Slightly Included	Slightly Included
Slightly Included	Included
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